

Polish

Symmetry

Fluorescence

Inscription(s)

Type IIa

## INTERNATIONAL GEMOLOGICAL INSTITUTE

## LABORATORY GROWN DIAMOND REPORT

ADDITIONAL GRADING INFORMATION

| December 28, 2024       |                          |
|-------------------------|--------------------------|
| IGI Report Number       | LG670402993              |
| Description             | LABORATORY GROWN DIAMOND |
| Shape and Cutting Style | ROUND BRILLIANT          |
| Measurements            | 6.32 - 6.36 X 3.95 MM    |
| GRADING RESULTS         |                          |
| Carat Weight            | 0.99 CARAT               |
| Color Grade             | G                        |
| Clarity Grade           | VS 2                     |
| Cut Grade               | IDEAL                    |

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

EXCELLENT

1/31 LG670402993

NONE

## ELECTRONIC COPY

## LG670402993



Sample Image Used





IGI Report Number LG670402993 ROUND BRILLIANT LABORATORY GROWN DIAMOND 6.32 - 6.36 X 3.95 MM Carat Weight 0.99 CARAT Color Grade Clarity Grade VS 2 Cut Grade IDEAL Polish EXCELLENT Symmetry EXCELLENT NONE Fluorescence Inscription(s) (150 LG670402993 Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

| December 28, 2024 |  |
|-------------------|--|

| IGI Report Numbe<br>ROUND BRILLIANT               | r LG670402993    |  |
|---|------------------|--|
| LABORATORY GROWN DIAMOND<br>6.32 - 6.36 X 3.95 MM |                  |  |
|   |                  |  |
| Color Grade                                       | G                |  |
| Clarity Grade                                     | VS 2             |  |
| Cut Grade   | IDEAL            |  |
| Polish  | EXCELLENT        |  |
| Symmetry  | EXCELLENT        |  |
| Fluorescence                                      | NONE             |  |
|   | 1691 LG670402993 |  |
| Comments: This Laboratory Grown                   |                  |  |
| Diamond was cre                                   |                  |  |
| Chemical Vapor Deposition (CVD)                   |                  |  |
| growth process. Ty                                | rpe lla          |  |
|   |                  |  |

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